IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: YAMAGISHI, Yasuo, et al.

Group Art Unit: 2829

Serial No.: 10/621,445

Examiner: Jermele M. HOLLINGTON

Filed: July 18, 2003

P.T.O. Confirmation No.: 1112

For: PROBE CARD AND TESTING METHOD OF SEMICONDUCTOR CHIP, CAPACITOR AND MANUFACTURING METHOD THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 19, 2005

Sir:

This Preliminary Amendment is being filed concurrently with a Request for Continued Examination in response to the Final Office Action dated June 27, 2005, extended to October 27, 2005 by a one (1) month Petition for Extension of Time. Prior to further examination, please amend the above-identified application as follows: